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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
MAEGAWA, Tadashi et al

New York, New York  
Date: August 30, 2005

Serial No.: 10/789,870 Group Art Unit: 2812  
Date Filed: February 26, 2004  
For: SUBSTRATE PROCESSING APPARATUS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

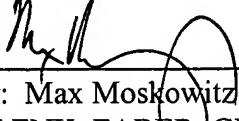
**STATUS INQUIRY LETTER**

Sir:

We filed the above application with the U. S. Patent and Trademark Office on February 26, 2004.

As of this date, we have not received a first Office Action from the Patent Office. Kindly advise us of the status of this application.

Respectfully Submitted,

  
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